



Supplementary Materials

The Effect of Silane Coupling Agent on the Texture and Properties of In Situ Synthesized PI/SiO₂ Nanocomposite Film

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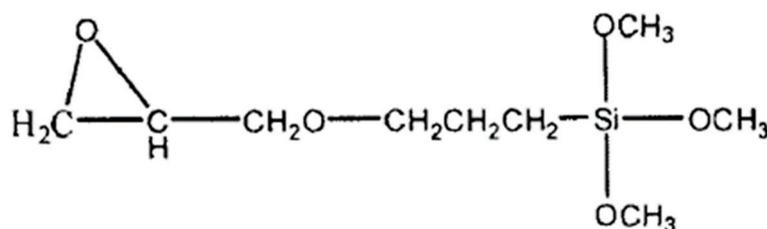


Figure S1. The molecular structure of KH-560.

Table S1. Composition of PI/SiO₂ composite film obtained by using different additive amount of silane coupling agent.

Sample	Mass (g)				Coupling agent ac- counts for SiO ₂ mass percentage (%)	SiO ₂ mass percentage (%)	Solid content of PAA solution (%)
	SiO ₂	TFDB	6FDA	DMAc			
PI	0	3.203	4.532	77.735	0	0	9.95
PIS10	0.877	3.210	4.531	77.743	0	10.17	9.98
PIS10-560-1	0.876	3.206	4.530	77.741	1.02	10.17	9.95
PIS10-560-3	0.878	3.207	4.529	77.740	3.05	10.19	9.95
PIS10-560-6	0.878	3.209	4.532	77.743	6.01	10.18	9.96
PIS10-560-10	0.878	3.208	4.531	77.742	10.03	10.19	9.95

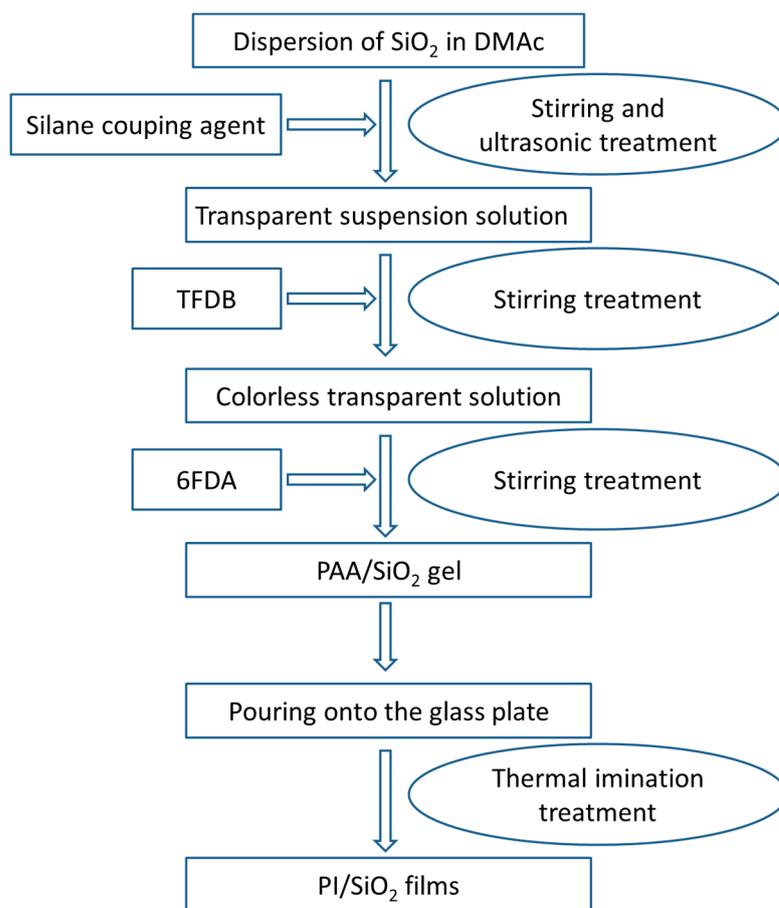


Figure S2. The schematical diagram of PI/SiO₂ films.

Table S2. The transmittance of PI/SiO₂ films before and after irradiation.

Sample	Maximum Transmittance (%)		Attenuation Rate (%)
	Before	After	
PIS10	87.6	86.3	1.48
PIS10-560-1	86.6	85.4	1.38
PIS10-560-3	86.9	85.7	1.38
PIS10-560-5	85.2	84.1	1.29
PIS10-560-10	84.9	83.8	1.29